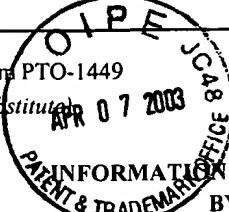


<p>Form PTO-1449 _(Substituted) APR 07 2003  INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use several sheets if necessary)</i></p>				Attorney Docket Number LAZE-01000US0 SRM/MLR	Serial/Patent Number 09/465,592
				Applicant/Patent Owner Culver, Rust	
				Filing/Issue Date 12/17/99	Group Art Unit 2653

U.S. PATENTS

Examiner Initial		Patent Number	Issue Date	First Named Inventor	Class	Subclass	Filing Date
<i>kc</i>	1.	5,822,285	10/13/98	Rugar et al.	369	44.26	03/31/97
<i>kc</i>	2.	5,835,477	11/10/98	Binnig et al.	369	126	07/10/96
<i>gr</i>	3.	5,856,967	01/05/99	Mamin et al.	369	126	08/27/97

U.S. PATENT PUBLICATIONS

Examiner Initial		Patent Application Publication Number	Publication Date	Applicant
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APR 10 2003**PENDING U.S. PATENT APPLICATIONS**

Examiner Initial		Application Number	Filing Date	First Named Inventor	Technology Center 2600 Petition to Expunge? Yes No

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Publication Date	Country	Class	Subclass	Trans-lation Yes No

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<i>kc</i>	4.	Barrett, R.C. and Quate, C.F., "Large-scale charge storage by scanning capacitance microscopy," Ultramicroscopy 42-44 (1992) pp. 262-267.
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Examiner	<u>Kim Chm</u>
	Date Considered <u>5/15/03</u>

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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